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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

de Larios, John M.

Application No. 10/608,871

Filed: June 27, 2003

For: Method and Apparatus for Removing a Target
Layer from a Substrate Using Reactive Gases

Group Art Unit: 1746

Examiner: Stinson, F.

Atty. Docket No. LAM2P422

Date: January 29, 2008

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on January 29, 2008.

Signed

Cynthia C. Lorente

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Alexandria, VA 22313-1450

Dear Sir:

The references listed in the attached PTO Form 1449, copies of which are attached, may be material to examination of the above-identified patent application. Applicants submit these references in compliance with their duty of disclosure pursuant to 37 CFR §§ 1.56 and 1.97. The Examiner is requested to consider these references and to acknowledge such consideration by initialing the attached PTO Form 1449 at the appropriate locations.

The fee of \$180.00 set forth in 37 C.F.R. § 1.17(p) is attached hereto. The Commissioner is authorized to charge any additional fees that may be due to our Deposit Account No. 50-0805 (Order No. LAM2P422).

This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that these references indeed constitute prior art.

Respectfully submitted,
MARTINE PENILLA & GENCARELLA, LLP

Michael L. Gencarella, Esq.
Reg. No. 44,703

710 Lakeway Drive, Suite 200
Sunnyvale, CA 94085
Telephone: (408) 749-6900
Customer Number 25920

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